MEMS based Hand Gesture Wheel Chair Movement Control for Disable Persons

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Abstract

This project is to develop a wheel chair control which is useful to the physically disabled person with his hand movement or his hand gesture recognition using MEMS technology. The use of powered wheel chair with high navigational intelligence is one of the great steps towards the integration of severely physically disabled people. Driving wheel chair in domestic environments is a difficult task for people with arm or hands impairments. The wheel chair is developed to overcome the above problem described above allowing the end users to just perform safe movements and accomplish some daily life important tasks.

Keywords: MEMS, Powered wheel chair

1. Introduction

The main aim of this paper is to controlling a wheel chair and electrical devices by using MEMS. MEMS accelerometer sensor is micro electro-mechanical sensor which is a highly sensitive sensor and capable of detecting the tilt. This sensor finds the tilt and makes use of the accelerometer to change the direction of the wheel chair depending on tilt. For example, if the tilt is to the right side then the wheel chair moves in right direction or if the left side then wheel chair left direction. Wheel chair movement can be controlled in forward. This project makes use of microcontroller, which is programmed, with the help of Embedded C instructions. This microcontroller communicates with the ADC and motor driver. The MEMS Accelerometer Sensor based sensor detects tilt and provides the information to the microcontroller and the controller judges whether the instruction is right movement or left movement instruction and controls the direction respectively. The controller is interfaced with two dc motors to control the direction of the wheel chair. To perform the task the controller is loaded with intelligent program written using Embedded C language.

2. Our proposed work

3-axis Accelerometer sensor

This small and highly sensitive accelerometer can detect acceleration, inclination and vibration by measuring the motion in the x-, y-, and z-axis simultaneously. By sensing the mounting angle, the sensor can assist in compensating for the devices mounting angle, and here for ekes it possible to use normal SMD technology in high density boards, and also to realize the precise detection of the inclination angle. An interface IC within the sensor package also has temperature sensing and self-diagnosis functions.

Principle of detection

Piezo Resistor

![Figure 1 Principle of Detection](image-url)
3. Related Work and Motivation

![Figure 2: MEMS Sensor](image)

The ADXL335 is a small, thin, low power, complete 3-axis accelerometer with signal conditioned voltage outputs. The product measures acceleration with a minimum full-scale range of ±3 g. It can measure the static acceleration of gravity in tilt-sensing applications, as well as dynamic acceleration resulting from motion, shock, or vibration. The user selects the bandwidth of the accelerometer using the CX, CY, and CZ capacitors at the Xout, Yout, and Zout pins. Bandwidths can be selected to suit the application, with a range of 0.5 Hz to 1600 Hz for the X and Y axes, and a range of 0.5 Hz to 550 Hz for the Z axis.

The ADXL335 is available in a small, low profile, 4 mm × 4 mm × 1.45 mm, 16-lead, plastic lead frame chip scale package.

Micro Electro Mechanical Systems (MEMS) is the integration of mechanical elements, sensors, actuators, and electronics on a common silicon substrate through micro fabrication technology. An accelerometer is an electromechanical device that measures acceleration forces. MEMS accelerometer is a single chip with small size and low cost. Because of their small size and weight, accelerometers are attached to the finger tips and back of the hand. In this model we are using MMA760FC accelerometer, which is 3-axis accelerometer and gives digital output (I2C).

4. Simulation implementation

This project is implemented using following software's:

- Keil software – for compilation part
- Proteus 7 (Embedded C) – for simulation part

**Keil software**

Keil Micro Vision: is free software which solves many of the pain points for an embedded program developer. This software is an integrated development environment (IDE), which integrated a text editor to write programs, a compiler and it will convert your source code to hex files too.
5. Proteus

Proteus is software which accepts only hex files. Once the machine code is converted into hex code, that hex code has to be dumped into the microcontroller and this is done by the Proteus. Proteus is a programmer which itself contains a microcontroller in it other than the one which is to be programmed. This microcontroller has a program in it written in such a way that it accepts the hex file from the keil compiler and dumps this hex file into the microcontroller which is to be programmed. As the Proteus programmer requires power supply to be operated, this power supply is given from the power supply circuit designed and connected to the microcontroller in proteus. The program which is to be dumped in to the microcontroller is edited in proteus and is compiled and executed to check any errors and hence after the successful compilation of the program the program is dumped in to the microcontroller using a dumper.

The working procedure of the project is when, the change in the hand gesture then the MEMS generates analog signal from mechanical signal and this is given to ADC which, converts analog to digital signal. Microcontroller doesn’t understand analog signal so the digital signals are given to it. According to the change in direction in the MEMS sensor the micro controller controls the motor direction by motor driver.

6. Hardware Implementation: The components involved in the paper are

1) MEMS sensor
2) ADC(0808)
3) Microcontroller(AT89S52)
4) H-bridge(L293D)
5) DC motors

This enables the sensor to detect the acceleration motion. MEMS sensor contain Tilt register. When the changes in direction, the tilt register values are changed and that values are given to ADC, which converts analog to digital values this values are given to microcontroller. Depending on the direction of the MEMS, microcontroller controls the wheel chair directions like LEFT, RIGHT, FRONT, and BACK. By implementing the above circuit, the obtained values are:

<table>
<thead>
<tr>
<th>position</th>
<th>X-axis</th>
<th>Y-axis</th>
</tr>
</thead>
<tbody>
<tr>
<td>Left</td>
<td>&gt;150&amp;&amp;&gt;200</td>
<td>&lt;200&amp;&amp;&lt;250</td>
</tr>
<tr>
<td>Right</td>
<td>&gt;100&amp;&amp;&gt;200</td>
<td>&gt;150&amp;&amp;&gt;200</td>
</tr>
<tr>
<td>Forward</td>
<td>&gt;150&amp;&amp;&gt;200</td>
<td>&lt;200&amp;&amp;&lt;250</td>
</tr>
<tr>
<td>Backward</td>
<td>&gt;100&amp;&amp;&gt;200</td>
<td>&lt;150&amp;&amp;&lt;250</td>
</tr>
</tbody>
</table>

Conclusion

This paper is implemented using various components, the project is just a prototype if we make this project as commercial project, then definitely useful to all the disabled people, who are unable to move and unable to drive normal wheel chair their own. With their hand movements they can move wheel chair right, left, front, and back directions with 3-axis accelerometer(MEMS SENSOR) which is a highly sensitive sensor and capable of detecting the tilt. The future scope of the project can be extended using wireless technology, and intelligent hand gesture wheel chair.

References

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Wheel Chair Motion Control Based On Hand Gesture Recognition [JIRTS volume2 No2]